



2879

03500.015728.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
	:	Examiner: N. Y. A.
SHINICHI KAWATE ET AL.)	
	:	Group Art Unit: 2879
Application No.: 09/940,642)	
	:	
Filed: August 29, 2001)	
	:	
For: ELECTRON-EMITTING DEVICES,)	
ELECTRON SOURCES, AND	:	
IMAGE-FORMING APPARATUS)	September 9, 2003.

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the listed documents are also enclosed.

For a concise explanation of relevance for various non-English documents listed on the enclosed Form PTO-1449, the Examiner is directed to the corresponding English-language abstracts, English translations, and/or English counterparts, where available, as indicated in association with the relevant non-English documents on the Form PTO-1449.

For the concise statement of relevance of non-English document
CN 1181607A, the Examiner also is respectfully referred to English-language counterparts
EP 0 836 217 A1 and WO 99/58748.

The Examiner's attention is also directed to the following U.S. Applications:

<u>APPLICATION NO.</u>	<u>FILING DATE</u>	<u>GROUP ART UNIT</u>
09/178,680 (Allowed)	10/26/98	2879
09/506,289	2/18/00	2818
09/666,605	09/20/00	2811
09/955,137	9/19/01	2879
10/106,484	3/27/02	2879
10/234,213	9/5/02	2879
10/235,809	9/6/02	2878

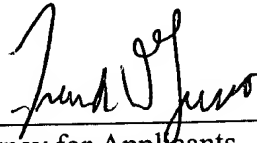
A copy of each cited application is enclosed.

It is respectfully requested that the above information be considered by the
Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such
information has been considered.

It is believed that no fee is required in connection with this paper. However, if
a fee is deemed required, please charge the fee to Deposit Account 06-1205.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

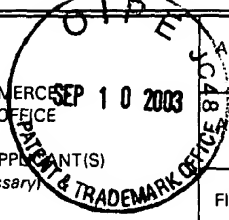


Attorney for Applicants

Registration No. 42,476

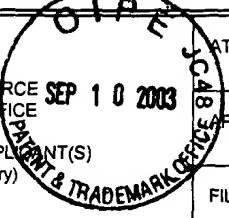
FITZPATRICK, CELLA, HARPER & SCINTO
30 Rockefeller Plaza
New York, New York 10112-3801
Facsimile: (212) 218-2200

NY MAIN_#373991v1

FORM PTO 1449 (modified)				ATTY DOCKET NO. 03500.015728.		APPLICATION NO. 09/940,642	
U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE				APPLICANT Shinichi Kawate et al.			
LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary)				FILING DATE August 29, 2001		GROUP 2879	
Date Submitted to PTO: [DATE]							
U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
	5,982,091	11/99	Konishi	313	495		
	2002/0031972 A1	03/02	Kitamura et al.	445	3		
	6,400,091 B1	06/02	Deguchi et al.	315	169.1		
	6,472,814 B1	10/02	Yamanobe et al.	313	495	11/13/98	
	5,872,422	02/99	Xu et al.	313	311		
	6,087,765	07/00	Coll et al.	313	309		
	2002/0009637A1	01/02	Murakami et al.	429	213	02/05/01	
	5,847,495	12/98	Yamanobe et al.	313	310		
	5,066,883	11/91	Yoshioka et al.	313	309		
	6,455,021 B1	09/02	Saito	423	447.3	07/20/99	
	6,471,936 B1	10/02	Chen et al.	423	658.2	03/02/00	
	5,773,921	06/30/98	Keesman et al.	313	309		
	5,973,444	10/26/99	Xu et al.	313	309		
	5,935,639	8/10/99	Sullivan et al.	427	78		
	4,956,578	9/11/90	Shimizu et al.	315	3		
	5,185,554	2/9/93	Nomura et al.	313	495		
	6,448,709	9/02	Chuang et al.	313	497		
	6,204,597	03/01	Xie et al.	313	310		
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Sheet 1 of 10

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	5,577,943	11/96	Vickers et al.	445	24		
	2002/136896	09/26/00	Takikawa et al.	428	408		
	5,192,240	03/09/93	Komatsu	445	24		
	5,214,346	05/25/93	Komatsu	313	309		
	5,382,867	01/17/95	Maruo et al.	313	309		
	5,612,587	03/18//97	Itoh et al.	313	309		
	6,313,572 B1	11/06/01	Yamada	313	310		
	6,135,839	10/24/00	Iwase et al.	445	24		
	6,283,812 B1	09/01	Jin et al.	445	24		
	2001/0006232	07/05/01	Choi et al.	257	10		
	4,816,289	03/89	Komatsu et al	423	447.3		
	5,443,859	08/95	Nagata	427	122		
	5,618,875	04/97	Baker et al.	524	495		
	5,690,997	11/97	Grow	427	249.1		
	6,129,602	10/00	Yamanobe	445	24		
	6,228,904	05/01	Yadav et al.	523	210		
	6,333,016	12/01	Resasco et al.	423	447.3		
	6,413,487	07/02	Resasco et al.	423	447.3		
	6,445,006	09/02	Brandes et al.	257	76		
	5,981,305	11/99	Hattori	438	20		
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	6,290,564	9/01	Talin et al.	445	50	
	5,458,784	10/95	Baker et al.	210	674	
	6,331,690 B1	12/01	Yudasaka et al.	219	121.6	
	5,965,267	10/99	Nolan et al.	428	408	
	6,309,612 B1	05/02	Kotaki et al.	347	85	
	5,872,541	02/99	Yoshioka et al.	345	74.1	
	5,543,684	08/96	Kumar et al.	313	495	
	5,551,903	9/96	Kumar et al.	445	24	
	4,900,483	2/90	Witzke et al.	313	309	
	5,500,200	3/96	Mandeville et al.	423	447.3	
	5,726,524	3/98	Debe	313	309	
	2002/0047562 A1	04/25/02	Kitamura et al.	315	169.3	05/29/01
	5,770,918	06/98	Kawate et al.	313	495	
	5,185,554	02/93	Nomura et al.	313	495	
	2002/0146958 A1	10/02	Ono et al.	445	24	
	2003/0048056 A1	03/03	Kitamura et al.	313	311	
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	0 535 953 B1	01/96	EPO	H01J	1/30	English
	0 290 026 B1	02/93	EPO	H01J	3/02	English
	1 122 344 A2	08/01	EPO	D01F	9/127	English
	WO 01/93292 A1	12/01	PCT	H01J	1/304	English
	WO 89/07163	08/10/89	Japan	D01F	9/12	English
	WO 90/07023	06/28/90	PCT	D01F	9/12	English
	08-115652	05/07/96	Japan	H01J	1/30	Abst. & Trans.
	0 758 028 A2	02/12/97	EPO	D01F	9/127	English
	WO 98/05920	02/12/98	PCT	G01B	7/34	English
	0 394 698 A2	10/31/90	EPO	H01J	1/30	English
	2000/277003	10/06/00	Japan	H01J	9/02	Counterpart U.S. Patent 2002/136896
	0 797 233 A2	09/24/97	EPO	H01J	1/30	English
	0 980 089 A1	02/16/00	EPO	H01J	1/30	English
	0 986 084 A2	03/15/00	EPO	H01J	1/30	English
	1 117 118 A1	07/18/01	EPO	H01J	1/312	English
	0 716 439 A1	06/12/96	EPO	H01J	3/02	English
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2-112125	04/24/90	JAPAN	H01J	1/30	Abst. & Counterpart U.S. Patent 4,956,578	
3-20941	01/29/91	JAPAN	H01J	31/12	Abst. & Counterpart U.S. Patent 5,185,554	
5-211029	08/20/93	JAPAN	H01J	1/30	No	
8-264109	10/11/96	JAPAN	H01J	1/30	Abst.	
9-82214	3/28/97	JAPAN	H01J	1/30	Abst. & European Equivalent 0 716 439	
1 113 478 A1	07/01	EPO	H01J	3/02	English	
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A1 443 865	08/28/91	EPO	H01J	21/10	English	
04-212236	03/08/92	Japan	H01J	1/30	Counterpart U.S. Patents 5,192,240, 5,214,346 & EP 0 443 865	
03-295131	12/26/91	Japan	H01J	1/30	Counterpart U.S. Patents 5,192,240, 5,214,346 & EP 0 443 865	
05-159696	06/25/93	Japan	H01J	1/30	Counterpart U.S. Patents 5,382,867 & EP 0 535 953	
05-198253	08/06/93	Japan	H01J	1/30	Counterpart U.S. Patents 5,382,867 & EP 0 535 953	
05-274997	10/22/93	Japan	H01J	1/30	Abst. & Counterpart U.S. Patent 5,612,587	

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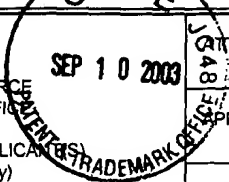
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		11-232997	08/27/99	Japan	H01J	1/30	Counterpart U.S. Patent 6,313,572 & EP 0 936 650
		A1 936 650	08/18/99	EPO	H01J	3/02	English
		10-289650	10/27/98	Japan	H01J	1/30	Counterpart U.S. Patent 6,135,839 & EP 0 871 195
		A1 871 195	10/14/98	EPO	H01J	1/30	English
		0 614 209 A1	9/94	EPO	H01J	31/12	English
		7-6714	1/95	Japan	H01J	31/12	Abst. & European Counterpart 0 614 209
		0 290 026 A1	11/88	EPO	H01J	3/02	English
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		1 022 763 A1	7/00	EPO	H01J	9/02	English
		2000-223005	8/00	Japan	H01J	1/304	Abst. & Counterpart U.S. Patent 6,283,812
		0 836 217 A1	04/98	EPO	H01J	29/94	English
		WO 99/58748	11/99	PCT	D01F	9/127	English
		CN 1181607A	5/98	China			English Counterparts 0 836 217 & 99/58748
		1 187 161 A2	03/13/02	EPO	H01J	3/02	English
		1 102 299 A1	5/01	EPO	H01J	1/30	English
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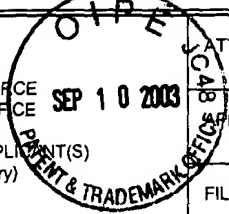
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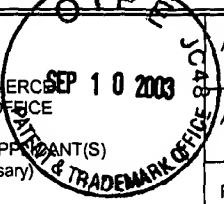
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	1 120 877 A1	8/01	EPO	H02G	5/06	English	
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	2001-288625 A	10/01	Japan	D01F	9/127	Abst., Counterpart U.S. Patent 2002/00009637 & EP 1 122 344	
	0 433 507 A1	6/91	EPO	D01F	9/127	English	
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		Q. H. Wang et al., "A Nanotube-Based Field-Emission Flat Panel Display," <i>Applied Physics Letters</i>, Vol. 72, No. 22, June 1998, pp. 2912-2913			
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